



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No. : 10/532,991 Confirmation No. : 2959
First Named Inventor : Mitsuhiro YUASA
Filed : April 28, 2005
TC/A.U. : 2812
Examiner : A. Roman

Docket No. : 101249.56268US
Customer No. : 23911

Title : Process Monitor and System for Producing Semiconductor

REPLY

Mail Stop RCE

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

The following amendments and remarks are respectfully submitted in response to the Final Office Action dated November 9, 2006, the period for response having been extended to April 9, 2007 by the attached Petition for Extension of Time.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper. *Additional claims fees are submitted herewith.*

Remarks begin on page 7 of this paper.

03/29/2007 MKAYPAGH 00000048 10532991

01 FC:1615 150.00 OP
02 FC:1614 400.00 OP